



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

January 2, 2026

IGI Report Number

LG761566098

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

SQUARE EMERALD CUT

Measurements

8.14 X 7.97 X 5.21 MM

GRADING RESULTS

Carat Weight

3.05 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish EXCELLENT

Symmetry EXCELLENT

Fluorescence NONE

Inscription(s)  LG761566098

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

LG761566098
Report verification at igi.org

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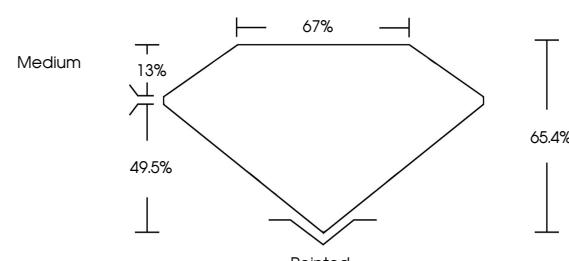
Color Grade

E

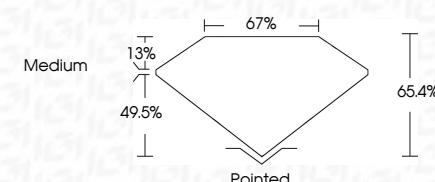
Clarity Grade

VVS 2

PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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Fluorescence NONE

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January 2, 2026	IGI Report No LG761566098
	SQUARE EMERALD CUT
	8.14 X 7.97 X 5.21 MM
Carat Weight	3.05 CARATS
Color Grade	E
Clarity Grade	VVS 2
Depth	66.4%
Table Grade	67%
Culet	Medium
Polish	Pointed
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG761566098

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